

Chihiro Uchibori

Group Art Unit: 2825

Application No.: 09/648,750

Examiner: Granville Lee

Filed: August 28, 2000

Docket No.: 108077-00000

FOR: METAL INTERCONNECTION, SEMICONDUCTOR DEVICE, METHOD FOR FORMING METAL INTERCONNECTION AND METHOD FOR FABRICATING

SEMICONDUCTOR DEVICE

PRELIMINARY AMENDMENT

Commissioner for Patents Washington, D.C. 20231

July 28, 2003

Sir:

In reply to the Office Action mailed February 26, 2003, the period for response being extended two months from May 26, 2003 to July 28, 2002 by the attached two-month Petition for Extension of Time, please amend the above-identified application as follows.

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